

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Masaru MITSUI et al.

Group Art Unit:

1752

Application No.:

09/509,472

Examiner:

Y. Thornton

Filed: April 21, 2000

Docket No.:

105875

For:

PHOTOMASK BLANK, PHOTOMASK, METHODS OF MANUFACTURING THE

SAME AND METHOD OF FORMING MICROPATTERN

SUPPLEMENTAL AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

As a supplement to the Amendment filed on July 13, 2004, please further consider the following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.